



RESPONSE UNDER 37 CFR 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 2851

00862.022438.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Yoshinori MIWA

Application No.: 09/987,568

Filed: November 15, 2001

For: EXPOSURE APPARATUS AND EXPOSURE
METHOD

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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: Examiner: H. Nguyen
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: Group Art Unit: 2851
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)
:
) August 7, 2003
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#9/BTH
Sub. Spec. (N/E)
8-13-03
JFR

RECEIVED
AUG 12 2003
TECHNOLOGY CENTER 2800

AMENDMENT AFTER FINAL REJECTION AND LETTER
FORWARDING SUBSTITUTE SPECIFICATION

Sir:

In response to the Official Action dated May 7, 2003, please amend the above-
identified application as follows:

Please do not
amend

8/17/03
HN